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Shery Neumann Date: Nov. 10, 2003

Office of Initial Patent Examination

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor:

Luca PUSTERLA,

et al.

Conf. No.:

7623

Group Art Unit: 1764

Appln. No.:

10/601,383

Examiner:

Not Yet Assigned

Filing Date:

June 23, 2003

§ Attorney Docket No.: 6023-169US

(BX2453M)

Title: METHOD FOR MEASURING THE CONCENTRATION OF IMPURITIES IN HELIUM

BY ION MOBILITY SPECTROMETRY

REQUEST FOR CORRECTED FILING RECEIPT

Attached is the original Filing Receipt for the above identified patent application. Please note that the date listed in the Domestic Priority data as claimed by applicant section and the Foreign Applications section is incorrect. Please list the information as follow:

Domestic Priority data as claimed by applicant

This application is a CON of PCT/IT02/00004 01/08/2002

Foreign Applications

ITALY MI2001A 000018 01/08/2001

Please make this correction and provide us with a Corrected Filing Receipt.

Respectfully submitted,

November 10, 2003 By:

WILLIAM W. SCHWARZE

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WWS:srn Enclosure

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 FILING OR 371 (c) DATE
 ART UNIT
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 DRAWINGS
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 IND CLMS

 10/601,383
 06/23/2003
 1764
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CONFIRMATION NO. 7623

000570

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PHILADELPHIA, PA 19103-7013

OCT - 1 2003

FILING RECEIPT

OC000000010929272

Date Mailed: 09/25/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

SAES GETTERS S.p.A.;

Domestic Priority data as claimed by applicant

01/08/2002

This application is a CON of PCT/IT02/00004 97/11/2002

F reign Applications

ITALY MI2001A 000018 08/01/2001 01/08/2001

If Required, Foreign Filing License Granted: 09/25/2003

Projected Publication Date: 01/01/2004

Non-Publication Request: No

Early Publication Request: No

Title

Method for measuring the concentration of impurities in helium by ion mobility spectrometry

Preliminary Class

422

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